

Docket No. 242768US90CONT  
IN RE APPLICATION OF: Yasutaka ITO, et al.  
SERIAL NO: 10/663,681  
FILED: September 17, 2003  
FOR: SEMICONDUCTOR PRODUCTION DEVICE CERAMIC PLATE



COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:  
Transmitted herewith is a Preliminary Amendment (9 pp.) in the above-identified application.

- ☒ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☒ Additional documents filed herewith: Search in issued U.S. patent abstracts for "wafer prober"  
Search in issued U.S. patent abstracts for "wafer prover"  
Google search for "wafer prober"  
Google search for "wafer prover"  
U.S. Patent No. 4,934,064  
U.S. Patent No. 5,773,951  
Information Disclosure Statement Under 37 C.F.R. §1.97  
List of Related Cases  
Cited Pending Applications (2)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	6	MINUS	20	0	x \$18 =	\$0.00
INDEPENDENT	1	MINUS	3	0	x \$86 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$290 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		TOTAL				\$0.00

- ☐ A check in the amount of \$0.00 is attached.
- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Masayasu Mori  
Registration No. 47,301

Customer Number  
**22850**

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 05/03)

Corwin P. Umbach, Ph.D.  
Registration No. 40,211

DOCKET NO: 242768US90CONT



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
YASUTAKA ITO, ET AL. : GROUP ART UNIT: 2811  
SERIAL NO: 10/663,681 :  
FILED: SEPTEMBER 17, 2003 : EXAMINER:  
FOR: SEMICONDUCTOR PRODUCTION :  
DEVICE CERAMIC PLATE

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the application identified above as follows.

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks** begin on page 8 of this paper.